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United States Patent [19]

Ohmi et al.

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[54]	PARALLEL PLATE SPUTTERING DEVICE
	WITH RF POWERED AUXILIARY
	ELECTRODES AND APPLIED EXTERNAL
	MAGNETIC FIELD

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[22] Filed: Mar. 5, 1998

Mar. 7, 1997

[30] Foreign Application Priority Data

[51]	Int. Cl. ⁷		 C23C	14/34
		20		

[JP] Japan 9-070431

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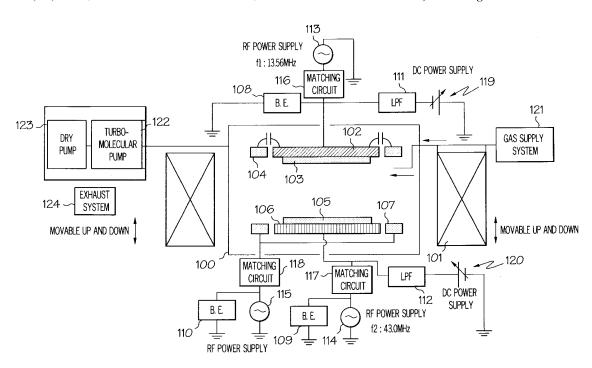
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Primary Examiner—Nam Nguyen Assistant Examiner—Gregg Cantelmo Attorney, Agent, or Firm—Randall J. Knuth

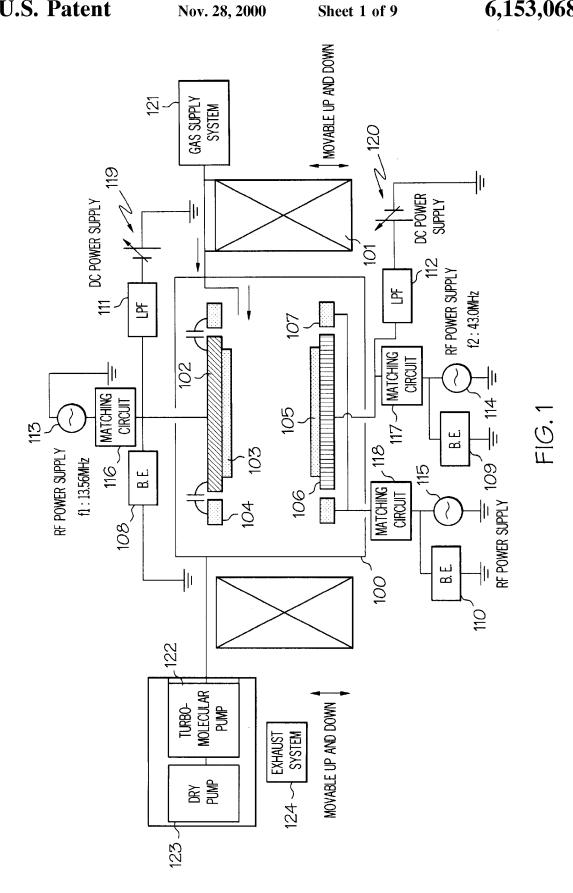
57] ABSTRACT

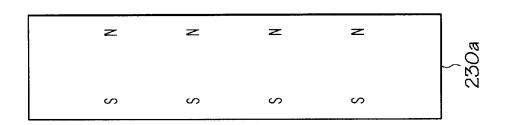
The present invention provides a sputtering device provided with two electrodes I and II of parallel plate type within a vessel inside which pressure can be reduced, wherein: a target to be sputtered is placed on said electrode I, and a base body on which a film is to be deposited is placed on said electrode II, with the target and the base body being opposed to each other; a process gas is introduced into said vessel from a gas supply system; radio frequency power is applied to said target through at least said electrode I so as to excite plasma between the electrode I and the electrode II; characterized in that: outside said vessel, is provided a means for introducing magnetic field horizontal at least to a surface to be sputtered of said target.

2 Claims, 9 Drawing Sheets

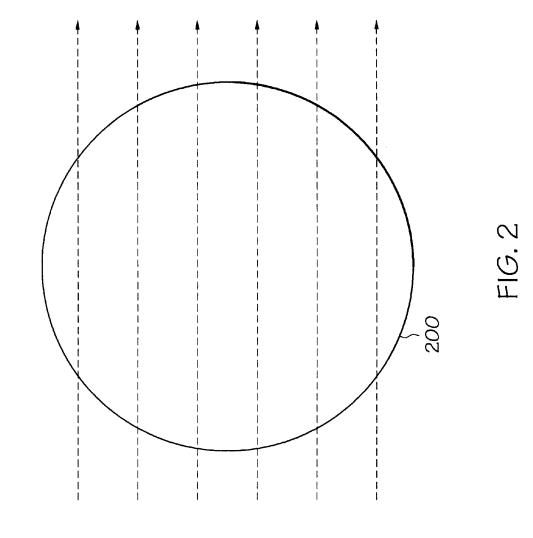


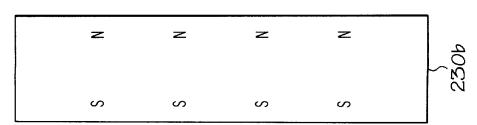






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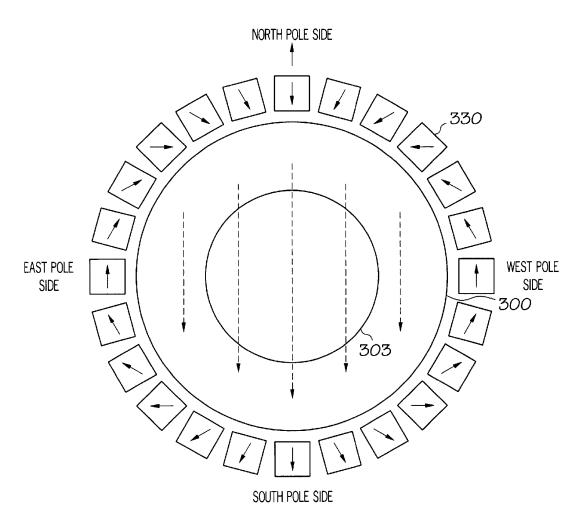
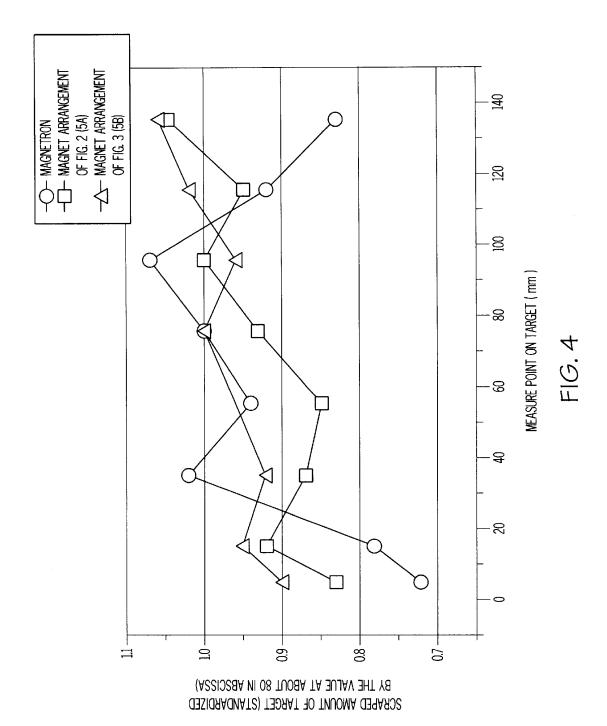


FIG. 3



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